

Notice of References Cited	Application/Control No. 09/902,340	Applicant(s)/Patent Under Reexamination CHOU ET AL.	
	Examiner Martin J Angebranndt	Art Unit 1756	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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	N	08-007219	01-1996	Japan	Inaba et al.	**
	O	05-004896	01-1993	Japan	Taniguchi et al.	**
	P					
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NON-PATENT DOCUMENTS

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*	V	Dischler et al., "Infared and Raman Analysis of hydrogenated amorphous carbon films prepared by RF plasma deposition from ...", conference proceedings ISPC-7 Eindhoven, July 1985 (paper A-1-4)
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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